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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/542,289  
Filing Date: July 15, 2005  
Applicant: Yuichi SETSUHARA, et al.  
Group Art Unit: 2821  
Examiner: David Hung Vu  
Title: HIGH FREQUENCY POWER SUPPLY DEVICE AND  
PLASMA GENERATION DEVICE  
Attorney Docket: 12480-000134/US

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
Mail Stop **AMENDMENT**

March 10, 2009

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Dear Sir:

In response to the Office Action mailed December 10, 2008, the following amendments and remarks are respectfully submitted in connection with the above-referenced application.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 9 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	24	-	31	=	0
<b>Independent</b>	1	-	3	=	0